Substitute for form 1448A/PTO	Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many shaets as necessary)	Application Number	10/593,107	
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Sheet 1 of 1	Attorney Docket No: 7	989P003	

US PATENT DOCUMENTS					
					Pages, Columns,
			Publication		Lines, Where Relevant
Examiner	Cite	USP Document	or issue Date	Name of Patentee or Applicant	Passages or Relevant
Initial *	No '	Number	MM-DD-YYYYY	of cited Document	Figures Appear

FOREIGN PATENT DOCUMENTS						
		Foreign Patent Document			Pages, Columns, Lines,	
Examiner	Cite	Country Code/Number/Kind Code	Publication Date	Name of Patentee or Applicant of	Where Relevant Passages	1 . 1
Initials*	No '	(if known)	MM-DD-YYYY	cited Document	or Relevant Figures Appear	L

	Ol	THER DOCUMENTS NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T2
		CHU, CHEN F., et al., "Comparison of p-Side Down and p-Side Up GaN Light-	
	1 1 2 2 3 4 5 6 6 6 7 7	Emitting Diodes Fabricated by Laser Lift-Off', <u>Japan Journal of Applied Physics</u> , Vol. 42, (02/15/2003), 147-150	
		LI, WH., et al., "Electrochemical deposition of Copper on patterned Cu/Ta(N)SiO2 surfaces for super filling of sub-micron features", <u>Journal of Applied Electrochemistry</u> , Vol. 31, (2001), 1395-1397	

EXAMINER DATE CONSIDERED